

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant	:	Heiner et al.
App. No	:	10/762,931
Filed	:	January 21, 2004
For	:	CHEMICAL REACTION MONITOR
Examiner	:	Paul Sang Hwa Hyun
Art Unit	:	1797
Conf No.	:	5755

**RESPONSE AFTER FINAL OFFICE ACTION**

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This is a response to the final Office Action issued June 24, 2010 in connection with the above-referenced patent application. Applicants wish to thank Examiner Hyun for the time and courtesy extended during the interview of November 9, 2010. Applicants requests that the Examiner enter the following amendments and consider the following remarks.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Summary of Interview** begins on page 8 of this paper.

**Remarks** begin on page 9 of this paper.